



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/051,981  
Filing Date ..... January 16, 2002  
Inventor ..... Zhongze Wang  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Jennifer M. Kennedy  
Attorney's Docket No. .... MI22-1797  
Title ..... Semiconductor-on-Insulator Comprising Integrated Circuitry

**EXPRESS ABANDONMENT TO PERMIT CONSIDERATION OF**  
**INFORMATION DISCLOSURE STATEMENT**  
**IN CONTINUING APPLICATION**  
**(37 C.F.R. § 1.313)**

To: Office of Petitions  
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**VIA HAND-DELIVERY**

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Applicant has separately filed a Petition For Withdrawal From Issue of this application to permit consideration of an Information Disclosure Statement under 37 C.F.R. § 1.97 in a continuing application. The continuation application is being filed concurrently with this Petition.

Applicant hereby abandons this application as of the time the Petition To Withdraw From Issue in this application is granted and when the continuing application is granted a filing date so as to make this application co-pending with said continuing application.

Respectfully submitted,

Dated: \_\_\_\_\_

3/25/04

By: \_\_\_\_\_



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